

00862.022497.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Prior Examiner: Thao X. Le
KIYOFUMI SAKAGUCHI, et al.)	
	:	Prior Group Art Unit: 2814
Application No.: Not Yet Assigned)	
	:	
Filed: Concurrently Herewith)	
	:	
For: THIN-FILM SEMICONDUCTOR)	
DEVICE AND METHOD OF	:	
MANUFACTURING THE SAME)	October 17, 2003

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CLAIM TO PRIORITY

Sir:

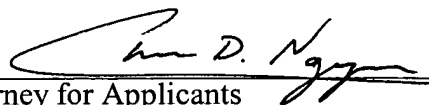
Applicants hereby claim priority under the International Convention and all rights to which they are entitled under 35 U.S.C. § 119 based upon the following Japanese priority application:

Japan 2001-023848, filed January 31, 2001.

A certified copy the above-referenced priority documents was submitted in parent Application No. 10/059,116.

Applicants' undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


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